## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Masahiro ITO, et al.

SERIAL NO: NEW APPLICATION

FILED:

**HEREWITH** 

FOR:

PROCESS FOR PRODUCING A FLUORINE ATOM-CONTAINING SULFONYL FLUORIDE

**COMPOUND** 

## **REQUEST FOR PRIORITY**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

T

SIR:			
	S. Application Serial Number 10/442 f PCT/JP01/10407, filed November 2	2,227, filed May 21, 2003, which was 28, 2001, is claimed pursuant to the	
☐ Full benefit of the filing date(s) of §119(e):	· · · · · · · · · · · · · · · · · ·	nimed pursuant to the provisions of <b>35 U.S</b> <u>Date Filed</u>	i.C
Applicants claim any right to prior the provisions of 35 U.S.C. §119, a		s to which they may be entitled pursuant to	)
In the matter of the above-identified ap	plication for patent, notice is hereby	given that the applicants claim as priority:	:
COUNTRY Japan	APPLICATION NUMBER 2000-361450	MONTH/DAY/YEAR November 28, 2000	
Certified copies of the corresponding C	Convention Application(s)		
☐ will be submitted prior to paym	ent of the Final Fee		
were filed in prior application S	Serial No. 10/442,227 filed May 21, 2	2003	
		nber y manner under PCT Rule 17.1(a) has bee	n
☐ (A) Application Serial No.(s) w	ere filed in prior application Serial N	No. filed ; and	
☐ (B) Application Serial No.(s)			
☐ are submitted herewith			

□ will be submitted prior to payment of the Final Fee

Respectfully Submitted,

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